03-01-09 Date Mailed

Date Mailed: February 27, 2004

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In reasonication of:

Wenxin Yu, et al.

Appl. No. 10/772,491

Filed: February 4, 2004

For:

ELECTROPHORETIC DISPLAY WITH

A BI-MODAL PARTICLE SYSTEM

Art Unit: Not Yet Assigned

Examiner: Not Yet Assigned

Atty. Docket: 07783.0035.NPUS01

## **Information Disclosure Statement**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Listed on accompanying Form PTO-1449 are documents that may be considered material to the examination of this application, in compliance with the duty of disclosure requirements of 37 C.F.R. §§ 1.56, 1.97 and 1.98.

Where the publication date of a listed document does not provide a month of publication, the year of publication of the listed document is sufficiently earlier than the effective U.S. filing date and any foreign priority date so that the month of publication is not in issue. Applicants have listed publication dates on the attached PTO-1449 based on information presently available to the undersigned. However, the listed publication dates should not be construed as an admission that the information was actually published on the date indicated.

Applicants reserve the right to establish the patentability of the claimed invention over any of the information provided herewith, and/or to prove that this information may not be prior art, and/or to prove that this information may not be enabling for the teachings purportedly offered.

This statement should not be construed as a representation that a search has been made, or that information more material to the examination of the present patent application does not exist. The Examiner is specifically requested not to rely solely on the material submitted

herewith. It is further understood that the Examiner will consider information that had been cited by or submitted to the U.S. Patent and Trademark Office in a prior application relied on under 35 U.S.C. § 120. 1138 OG 37, 38 (May 19, 1992).

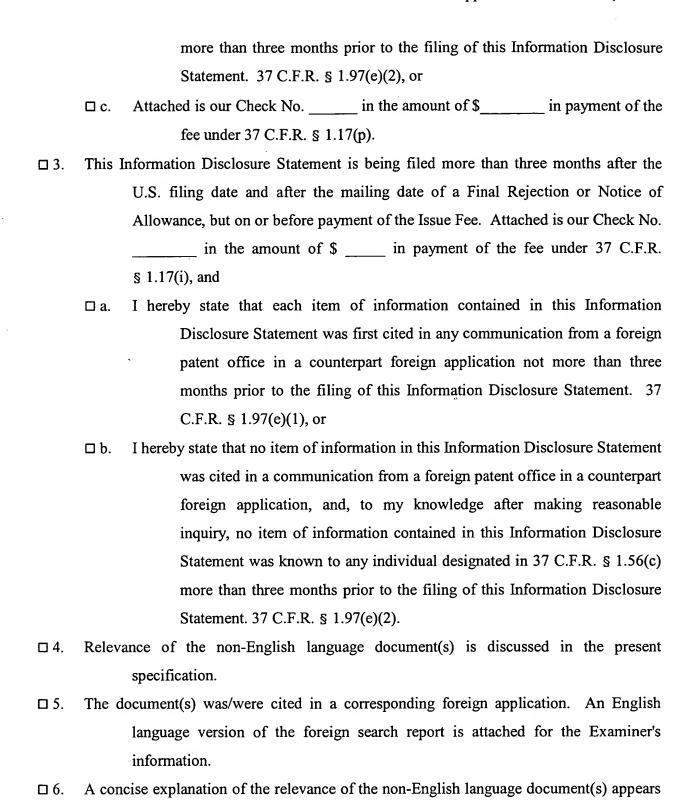
Applicants have checked the appropriate boxes below.

- 1. This Information Disclosure Statement is being filed;
  - a. Within three months of the U.S. filing date of a national application other than a continued prosecution application under §1.53(d);
  - □ b. Within three months of the date of entry of the national stage as set forth in §1.491 in an international application;
  - □ c. Before the mailing date of a first Office Action on the merits;
  - □ d. Before the mailing of a first Office Action after filing of a request for continued examination under § 1.115.

No statement under 37 C.F.R. § 1.97(e) or fee is required.

or;

- □ 2. This Information Disclosure Statement is being filed after the period specified in paragraph 1(a)-1(d) above, but before the mailing date of a Final Rejection or Notice of Allowance, or action that otherwise closes prosecution in the application, and
  - □ a. I hereby state that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. § 1.97(e)(1), or
  - □ b. I hereby state that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to my knowledge after making reasonable inquiry, no item of information contained in this Information Disclosure Statement was known to any individual designated in 37 C.F.R. § 1.56(c)



below:

<b>7</b> .	The Examiner's attention is directed to co-pending U.S. Patent Application No.
	, filed, which is directed to related technical subject matter.
	The identification of this U.S. Patent Application is not to be construed as a
	waiver of secrecy as to that application now or upon issuance of the present
	application as a patent. The Examiner is respectfully requested to consider the
	cited application and the art cited therein during examination.
□ 8.	Copies of the documents were cited by or submitted to the Office in Application No.
	, filed, which is relied upon for an earlier filing date under
	35 U.S.C. § 120. Thus, copies of these documents are not attached. 37 C.F.R.
	§ 1.98(d).

It is respectfully requested that the Examiner initial and return a copy of the enclosed PTO-1449, and to indicate in the official file wrapper of this patent application that the documents have been considered.

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 08-3038 referencing docket number 07783.0035.NPUS01.

Respectfully submitted,

Date: February 27, 2004

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			ATT	Y. DOCKET NO.		SEF	RIAL NO.		
INFORMATION DISCLOSURE CITATION SUPPLEMENTAL PTO-1449			07783.0035.NPUS01			10/772,491			
				APPLICANT					
			Wenxin Yu, et al.						
			FILING DATE		GROUP				
			February 4, 2004			Not Yet Assigned			
	•	U	.S. PA	TENT DOCUMENTS	<u> </u>				
EXAMINE R'S INITIALS	PATENT NO.	DATE		NAME		ASS	SUBCLASS	FILING DATE	
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d07	Sheet 2
MADENTANA	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)
<b>1</b>	Allen, K., « Electrophoretics Fulfilled », iSuppli Corporation, Emerging Displays Review, Oct. 2003, pp 1-19
*	Chen, S.M., « The Applications for the Revolutionary Electronic Paper Technology », OPTO News & Letters, 2003, July, 102, pp 37-41 (in Chinese, English abstract attached, full translation available upon request)
ł	Chen, S.M., « The New Applications and the Dynamics of Companies », TRI, May, 2003 (in Chinese, English abstract attached, full translation availabe upon request)
4	Chung, J. Et al. « Microcup(R) Electrophoretic Displays, Grayscale and Color Rendition », IDW '03, pp 243-246
Ÿ	Dalisa, A. L., IEEE Trans. Electr. Dev., Ed. 24, p. 827 (1977)
*	Hopper, M.A. and Vovotny, V. IEEE Trans. Electr. Dev., 26(8), 1148-1152 (1979)
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+	Liang, R.C. and Tseng, S., « Microcup(R) LCD, A New Type of Dispersed LCD by A Roll-to-Roll Manufacturing Process », IDMC '03, Taipei, Liang, Paper We-02-04
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t	Murau P. and Singer B., J. Appl. Phys., 49(9), 4820 (1978)
Ÿ	Patton, T. C., "Paint Flow and Pigment Dispersion", 2 <sup>nd</sup> ed., John Wiley & Sons, 1979
1	Zang, H.M. and Liang, R.C., « Microcup Electronic Paper by Roll-to-Roll Manufacturing Processes », Spectrum, 2003, 16/2, pp16-21
EXAMINER:	DATE CONSIDERED:

EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant. \*If an asterisk is placed beside the reference number, a copy is not provided because the reference was previously cited by or submitted to the PTO in a prior application that is identical in the statement and relied upon for an earlier filing date under 35 U.S.C. §120. 37 C.F.R. §1.98 (d).